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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/017,336	12/13/2001	Bill Peck	10010408	6785	
75	01/24/2003				
Gordon Stewart Agilent Technologies P.O. Box 7599			EXAMINER		
			LAIR, DONALD M		
Loveland, CO	80537-0599				
			ART UNIT	PAPER NUMBER	
			. 2858	,	
			DATE MAILED: 01/24/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

				NP			
		Application No.	Applicant(s)	7			
Office Action Summary		10/017,336	PECK, BILL				
		Examiner	Art Unit	-			
		Donald M Lair	2858				
Period fo	- The MAILING DATE of this communication r Reply	appears on the cover sheet	with the correspondence address				
THE N - Exten after: - If the - If NO - Failur - Any r	DRTENED STATUTORY PERIOD FOR RIMAILING DATE OF THIS COMMUNICATION Sions of time may be available under the provisions of 37 CF (SIX (6) MONTHS from the mailing date of this communication period for reply specified above is less than thirty (30) days, period for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by seply received by the Office later than three months after the rid patent term adjustment. See 37 CFR 1.704(b).	DN. FR 1.136(a). In no event, however, may a n. a reply within the statutory minimum of the eriod will apply and will expire SIX (6) MC statute, cause the application to become	a reply be timely filed irty (30) days will be considered timely. DNTHS from the mailing date of this communical ABANDONED (35 U.S.C. § 133).	tion.			
1)	Responsive to communication(s) filed on	•					
2a)	This action is FINAL . 2b)⊠	This action is non-final.					
3)	Since this application is in condition for a closed in accordance with the practice ur	llowance except for formal m nder <i>Ex parte Quayle</i> , 1935 (atters, prosecution as to the merit C.D. 11, 453 O.G. 213.	s is			
-	on of Claims			;			
4) Claim(s) 1-21 is/are pending in the application.							
	4a) Of the above claim(s) is/are with	ndrawn from consideration.					
·	Claim(s) is/are allowed.			i			
6)⊠ Claim(s) <u>1-21</u> is/are rejected.							
•	7) Claim(s) is/are objected to.						
•	Claim(s) are subject to restriction a	nd/or election requirement.					
• •	on Papers	miner					
•	Γhe specification is objected to by the Exar Γhe drawing(s) filed on <u>13 December 2001</u>		objected to by the Examiner				
10)[Applicant may not request that any objection						
11) 🗆 -	• •						
11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner. If approved, corrected drawings are required in reply to this Office action.							
12) The oath or declaration is objected to by the Examiner.							
,	inder 35 U.S.C. §§ 119 and 120			ĺ			
-	Acknowledgment is made of a claim for fo	reign priority under 35 U.S.C	. § 119(a)-(d) or (f).				
•—	☐ All b)☐ Some * c)☐ None of:						
-7.	1. Certified copies of the priority docur	ments have been received.					
	2. Certified copies of the priority documents have been received in Application No						
	3. Copies of the certified copies of the application from the International	priority documents have been Bureau (PCT Rule 17.2(a))	n received in this National Stage				
	see the attached detailed Office action for a						
-	cknowledgment is made of a claim for dor			ation).			
) \square The translation of the foreign languag Acknowledgment is made of a claim for do						
Attachmen	t(s)	_					
2) Notic	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-94) nation Disclosure Statement(s) (PTO-1449) Paper N	8) 5) Notice	w Summary (PTO-413) Paper No(s) of Informal Patent Application (PTO-152)	<u>.</u> ·			

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DETAILED ACTION

Specification

1. The specification is objected to as failing to provide proper antecedent basis for the claimed subject matter. See 37 CFR 1.75(d)(1) and MPEP § 608.01(o). Correction of the following is required: Claim 15 makes reference to a "polymeric ligand" which is not mentioned in the specification.

Claim Objections

2. Claim 8 is objected to because of the following informalities: The word "form" should be changed to - - from - -. Appropriate correction is required.

Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in-
- (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effect under this subsection of a national application published under section 122(b) only if the international application designating the United States was published under Article 21(2)(a) of such treaty in the English language; or
- (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that a patent shall not be deemed filed in the United States for the purposes of this subsection based on the filing of an international application filed under the treaty defined in section 351(a).
- 4. Claims 15 18 are rejected under 35 U.S.C. 102(e) as being anticipated by Kim et al. (US 2003/0008413).
- 5. In regards to Claim 15, Kim et al. disclose a method of detecting the presence of an analyte in a sample comprising contacting a biopolymeric array having a polymeric ligand that specifically binds to said analyte, with a sample suspected of comprising said analyte under conditions sufficient for binding of said analyte to a biopolymeric ligand on the array to occur,

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and detecting the presence of binding complexes on the surface of the array to detect the presence of the analyte in the sample (Claim 34).

- 6. In regards to Claim 16, Kim et al. disclose transmitting a result from the detecting step (Paragraph 91, lines 1 4).
- 7. In regards to Claim 17, Kim et al. disclose communicating the result to a remote location (Paragraph 91, lines 1-4).
- 8. In regards to Claim 18, Kim et al. disclose a method as applied to Claim 15 wherein data regarding a test sample is collected. It is inherent that there must be a way to receive data representing a result of the applied test in order to analyze the outcome otherwise the system would serve no function.

Claim Rejections - 35 USC § 103

- 9. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 10. Claims 1 14 and 19 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Schleifer et al. (US-6,242,266) in view of Gibson et al. (US-6,119,506).
- 11. In regards to Claim 1, Schleifer et al. disclose an apparatus comprising a body defining a chamber having first and second ports (Fig. 6, element 208), a first valve (Fig. 6, element 114; Column 10, lines 1-3) in communication with the first port, a second valve (Fig. 6, element 86; Column 10, lines 9-11) in communication with the second port, and a dry gas source (Fig. 6, element 88; Column 10, lines 6-7). Schleifer et al. teach that reagents typically used in the

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preparation of biopolymer arrays are water sensitive and that the presence of moisture should be eliminated or minimized; however, the reference fails to teach using a capacitive sensor probe in the chamber.

Gibson et al. teach using capacitive probes (Fig. 1, elements 102 and 104; Column 8, lines 47 - 51) in a closed chamber (Fig. 1, element 90; Column 8, lines 1 - 2) to detect the moisture content of the sample flowing across the probes (Column 9, lines 30 - 33).

Since Schleifer et al. teach that water can adversely affect the materials used in the production of biopolymer arrays and Gibson et al. teach a method of monitoring the moisture content of materials, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the chamber of the apparatus disclosed by Schleifer et al. to include a capacitance sensor probe as disclosed by Gibson et al. for the purpose of monitoring the moisture content of the current sample.

- 12. In regards to Claim 2, Schleifer et al. in view of Gibson et al. disclose positioning the valves to allow dry gas to flow through the chamber in one state (Schleifer et al., Column 3, lines 8-13 and 59-66) and to also allow a sample to flow through the chamber in another (Schleifer et al., Column 7, lines 27-31; Column 8, lines 13-14).
- 13. In regards to Claim 3, Schleifer et al. in view of Gibson et al. teach placing a vacuum pump in fluid communication with the chamber to draw sample material into the chamber (Schleifer et al., Column 11, lines 16 27; Column 7, lines 27 31).
- 14. In regards to Claim 4, Schleifer et al. in view of Gibson et al. teach using a venturi device as the vacuum pump (Schleifer et al., Column 7, lines 27 33).

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- 15. In regards to Claim 5, Schleifer et al. in view of Gibson et al. teach driving the venturi device with a dry gas source (Schleifer et al., Abstract, lines 15 17).
- 16. In regards to Claim 6, Schleifer et al. in view of Gibson et al. does not teach placing the ports of Claim 1 in an orthogonal arrangement, but does teach placing a third port (Schleifer et al., Column 11, lines 20 27) orthogonal to the first and second ports. Further, the third port disclosed by the reference is responsible for delivering reagents to the head similar to port (8) of the application. Therefore it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the apparatus disclosed by Schleifer et al. by placing the ports in an orthogonal arrangement for the purpose of drawing fluid in an upstream direction into the chamber.
- 17. In regards to Claim 7, Schleifer et al. in view of Gibson et al. do not teach using three-way valves in conjunction with two-way valves in the configuration disclosed by the applicant. However, the applicant uses the three-way valves for the purpose of being able to use a single venturi pump for drawing both dry gas and samples through the chamber. The Schleifer et al. reference discloses drawing both dry gas and samples through the chamber but teach using two dry gas and venturi sources (Schleifer et al., Column 11, lines 25 27), therefore the apparatus disclosed by the applicant is functionally identical to the valve/pump system disclosed by Schleifer et al. and is not patentable over the prior art of record.
- 18. In regards to Claim 8, Schleifer et al. in view of Gibson et al. teach flowing dry gas through the synthesis environment to purge the area of undesired components, especially moisture (Schleifer et al., Column 3, lines 8 13 and 59 66). The modified invention applied to Claim 1 has capacitance sensors in the synthesis environment/chamber, thus it is apparent that

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the dry gas used for purging the chamber of moisture will further purge the probes of moisture as well. The reference does not explicitly teach stopping the flow of dry gas through the chamber; however the disclosure makes it quite apparent that the gas is used to clear the chamber of any moisture prior to the process of drawing reagents in, therefore there is no question that the flow of dry gas must be terminated before any sample is introduced. The reference describes flowing sample reagents into the chamber (Schleifer et al., Column 11, lines 29 - 33), and thus also over the capacitance sensors of the modified invention.

- 19. In regards to Claim 9, Schleifer et al. in view of Gibson et al. teach the importance of keeping the reagents out of contact with moisture and further purging the chamber of moisture with a flow of dry gas. Gibson et al. teach placing the capacitive sensors in an insulated chamber. From these disclosures it would have been obvious to one of ordinary skill in the art at the time the invention was made that is important to minimize all reagent contact with moisture, and the modified invention as applied to Claim 1 does in fact isolate the capacitance sensors in the presence of dry gas for the purpose minimizing the amount of moisture in the chamber.
- 20. In regards to Claim 10, Schleifer et al. in view of Gibson et al. teach using negative pressure created by a venturi pump to draw sample through a flow-cell (Schleifer et al., Column 2, lines 55 60; Column 3, lines 8 10; Column 4, lines 13 15).
- 21. In regards to Claim 11, the apparatus disclosed by Schleifer et al. is used to produce biopolymers (Schleifer et al., Column 1, lines 26 27; Column 2, lines 36 38).
- 22. In regards to Claim 12, Schleifer et al. in view of Gibson et al. disclose producing a nucleic acid (Schleifer et al., Column 6, lines 14 21).

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- 23. In regards to Claims 13 and 14, Schleifer et al. in view of Gibson et al. disclose producing a biopolymer array (Schleifer et al., Column 1, lines 26 27; Column 2, lines 36 38; Column 8, lines 33 34).
- 24. In regards to Claim 19, Schleifer et al. in view of Gibson et al. disclose a chamber containing a capacitance sensor probe (Gibson et al., Fig. 1, elements 90, 102, and 104) and a dry gas source connected to a venturi device which produces a negative pressure within the chamber (Schleifer et al., Column 2, lines 55 60; Column 3, lines 8 10; Column 4, lines 13 15) to provide a flow of dry gas through the chamber (Schleifer et al., Column 3, lines 59 66).
- 25. In regards to Claim 20, Schleifer et al. in view of Gibson et al. disclose as applied to Claim 19 wherein the system is also configured to draw a sample gas into the chamber using negative pressure (Schleifer et al., Column 2, lines 55 60; Column 3, lines 8 10; Column 4, lines 13 15).
- 26. In regards to Claim 21, Schleifer et al. in view of Gibson et al. teach driving the venturi device with a dry gas source (Abstract, lines 15 17).

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Conclusion

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27. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. "Comparison of Moisture Sensors" discloses various types of capacitive probes, including a type that absorbs ambient moisture.

28. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Donald M Lair whose telephone number is (703) 305-4450. The examiner can normally be reached on Monday - Friday, 8 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, N. Le can be reached on (703) 308-0750. The fax phone numbers for the organization where this application or proceeding is assigned are 703-872-9318 for regular communications and 703-872-9319 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-1436.

Donald M. Lair Patent Examiner

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January 21, 2003

N. L

Supervisory Patent Examiner Technology Center 2800